

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Mamoru Nakasuji, et al.**

Serial No.: **Not yet assigned**

Filed: **January 29, 2004**

For: **ELECTRON BEAM APPARATUS AND METHOD OF
MANUFACTURING SEMICONDUCTOR DEVICE USING THE
APPARATUS**

Attorney Docket No.: 011470A
Customer Number: **38834**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 29, 2004

Sir:

Prior to calculation of the filing fee and examination of this application, please amend the above-identified application as follows:

Amendment to the Specification begins on **page 2** of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on **page 3** of this paper.

Remarks begin on **page 13** of this paper.